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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2851**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naruhide KITADA et al.

Group Art Unit: 2851

Application No.: 10/697,307

Examiner: M. KOVAL

Filed: October 31, 2003

Docket No.: 117563

For: MONITOR SYSTEM FOR PROJECTION APPARATUS, PROJECTION
APPARATUS, MONITOR PROGRAM FOR PROJECTION APPARATUS, AND
MONITOR METHOD FOR PROJECTION APPARATUS

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 17, 2006 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.

*Please
enter
amendment
MSK
5/14/06*